

UTILITY APPLICATION	Attorney Docket No.: ASMJP.137AUS
	First Named Inventor: Yasuyoshi Hyodo
	Title: METHOD OF FORMING SILICON-CONTAINING INSULATION FILM HAVING LOW DIELECTRIC CONSTANT AND LOW FILM STRESS
	Express Mail Label No.: EV 308022725 US
Direct all correspondence to Customer No.: 20995	
Date: August 20, 2003 Page 1 of 2	



Mail Stop Patent Application

United States Patent and Trademark Office
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The following enclosures are transmitted herewith to be filed in the patent application of:

Inventor(s):

- | | |
|----------------------|--------------------|
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| 3. Masashi Yamaguchi | 4. Atsuki Fukazawa |
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Assignee of this application: ASM JAPAN K.K.

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APPLICATION ELEMENTS:

(X) Specification in twenty-one (21) pages.

(X) Drawings in one (1) sheet.

OTHER APPLICATION PARTS:

(X) Information Disclosure Statement and PTO-1449 in 2 total pages (IDS and 1449).

(X) Four (4) references

(X) Return prepaid postcard.

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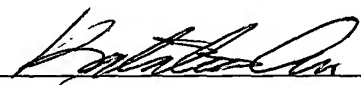
Page 2 of 2

FILING FEES:

FEE CALCULATION				
FEE TYPE		FEE CODE	CALCULATION	TOTAL
Basic Utility		1001 (\$750)		\$750
Excess Claims > 20	24 - 20 = 2	1202 (\$18)	2 x 18 =	\$36
Independent > 3	2 - 3 = 0	1201 (\$84)	0 x 84 =	\$0
			TOTAL FEE DUE	\$786

(X) A check in the amount of **\$786.00** to cover the Total Fee Due is enclosed.

The Commissioner is hereby authorized to charge any additional fees which may be required, now or in the future, or credit any overpayment to Account No. 11-1410.


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MAIL STOP PATENT APPLICATION
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


CERTIFICATE OF MAILING BY "EXPRESS MAIL"

Attorney Docket No. : ASMJP.137AUS
Applicant(s) : Yasuyoshi Hyodo, et al.
For : METHOD OF FORMING SILICON-
CONTAINING INSULATION FILM HAVING
LOW DIELECTRIC CONSTANT AND LOW
FILM STRESS
Attorney/Agent : Gordon H. Olson/Katsuhiro Arai
"Express Mail"
Mailing Label No. : EV 308022725 US
Date of Deposit : August 20, 2003

I hereby certify that the accompanying

Transmittal letter; specification in 23 pages; 1 sheet of drawings; Information
Disclosure Statement, PTO Form 1449 with 4 references; \$786.00 Check for
Filing Fee; Return Prepaid Postcard

are being deposited with the United States Postal Service "Express Mail Post Office to
Addressee" service under 37 CFR 1.10 on the date indicated above and are addressed to the
Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.


Kim Collins

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